

Supporting Information  
**Polar-Hydrophobic Ionic Liquid Induces Grain Growth and Stabilization in Halide  
Perovskites**

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## Experimental Section

### Materials Synthesis and Film Fabrication

All raw chemicals are obtained from Sigma-Aldrich, USA with further purification except when mentioned specifically. MA<sup>+</sup>TFA<sup>-</sup> ionic liquids (ILs) are synthesized via proton transfer between a Brønsted acid, trifluoroacetic acid and a weak base, methylamine. Anhydrous trifluoroacetic acid (Sigma-Aldrich, USA) and methylamine (MA, 33 wt.% in ethanol solution; Sigma-Aldrich, USA) are reacted in the equimolar amount. Since these reactions are very exothermic, the dropwise addition of the acid to the amine was carried out by cooling the amine solution to 0 °C using an ice water bath. The mixture was then stirred at room temperature for 6 hours. To ensure a complete reaction, an excess of amine was used and then removed in vacuum using a rotary evaporator.

### Film Fabrication:

For the deposition of MAPbI<sub>3</sub> perovskite thin films with on FTO-coated glass substrates, a 40 wt% PbI<sub>2</sub>:MAI (molar ratio 1:1) mixture was dissolved in the N,N-dimethylmethanamide (DMF) solvent, with different amount of MA<sup>+</sup>TFA<sup>-</sup> as the additive, were prepared. The solutions were spin-coated on the substrates at 4000 rpm for 20 s. The as-formed thin films were then annealed at 130 °C for 10 min. For obtaining better-quality thin films, the chlorobenzene-solvent-dripping process was introduced during the spin-coating step. Typically, the weight ratios of MA<sup>+</sup>TFA<sup>-</sup> and MAPbI<sub>3</sub> are 1:35, 1:25, 1:15 and 1:10, respectively.

**Materials and Thin-Film Characterization.** Qualitative analysis of as-synthesized MA<sup>+</sup>TFA<sup>-</sup> ILs has been carried out by Fourier-transform infrared spectroscopy (FTIR;

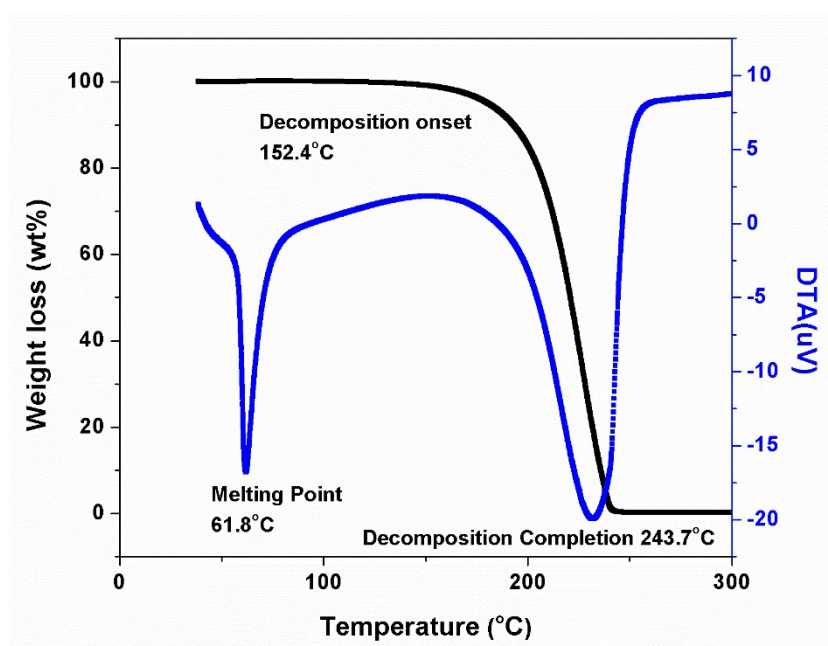
iS50, Nicolet, Thermo Scientific, USA) and  $^1\text{H}$  NMR (Advance III HD 400, Bruker, USA). Thermogravimetry and Differential Thermal Analyses (TG-DTA) of the samples were studied via a TG analyzer (DTG-60, Shimadzu, Japan) within the temperature range of 30 to 500 °C. The measurement process was carried out in the air with a heating rate of 10 °C/min. X-ray diffraction (XRD) patterns were collected using an X-ray diffractometer (D8 Discover, Bruker, Germany) using Cu K $\alpha$  radiation ( $\lambda=1.5406$  Å) at step size of 0.02°. 2D XRD were performed on an X-ray diffractometer with an in-situ heating stage (D8 Advance, Bruker, Germany). UV-vis absorption spectra were obtained on a UV-vis spectrometer (UV-2600, Shimadzu Scientific, Japan). Photoluminescence (PL) spectroscopy was performed on a spectrometer (FluoTime 300, PicoQuant, Germany) using 405 nm laser excitation. The surface and cross-sectional morphology and microstructure of samples were observed by a scanning electron microscopy (SEM; G500, ZEISS, Germany). Energy dispersive X-ray spectrometer (EDS; Octane Elite EDS System, EDAX, USA) attached to the SEM was employed for elemental analyses. The surface chemical compositions were measured using X-ray photoelectron spectroscopy (XPS; K-alpha, Thermo Scientific, USA).

**PSC Fabrication and Testing.** Patterned FTO-glass substrates were cleaned ultrasonically with an alconox (detergent) solution, followed by sonication in deionized water, acetone, and isopropyl alcohol sequentially for 20 min each. A 30-nm compact-TiO $_2$  layer was deposited on top of the etched FTO/glass substrates using the procedure described earlier. A 250-nm mesoporous-TiO $_2$  layer was then deposited by spin-coating followed by a sintering heat-treatment of 500 °C for 30 min in air. A 1.5 wt % solution of SnCl $_4$  in distilled water was spin-coated at 3000 rpm for 30 s. This is followed by annealing at 200 °C for 30 min, forming an ultrathin compact SnO $_2$  layer. The addition of SnO $_2$  coating is for purpose of enhancing the overall device open-circuit voltage and does not have an obvious effect on the solution wetting. The thin films of MAPbI $_3$  modified with or without the MA $^+$ TFA $^-$  additive were then deposited according to the procedure described above. A solution of Spiro-MeOTAD (Merck Group, Germany) hole-transporting material (HTM) coating was prepared by dissolving 72.3 mg of Spiro-MeOTAD in 1 mL of chlorobenzene (99.8%), to which 28.8  $\mu\text{L}$  of 4-tert-butyl pyridine (96%) and 17.5  $\mu\text{L}$  of lithium bis(trifluoromethanesulfonyl)imide (LITSFI) solution (520 mg LITSFI in 1 mL acetonitrile) were added. The HTM was deposited by spin-coating (3000 rpm, 30 s). Finally, a 100 nm Au electrode was thermally-evaporated to complete the solar cells. The current density-voltage (J-V) of the solar cells were measured using a Keithley 2400 sourcemeter under simulated AM1.5 illumination (100 mW cm $^{-2}$ ) simulated using a solar simulator (Sol3A Class AAA, Oriol, USA). A non-reflective mask (0.09 cm $^2$ ) was used to define the PSC area. The stabilized maximum-power outputs of the PSCs were measured by monitoring the J outputs at the maximum-power V bias (deduced from the reverse-scan J-V curves). The external quantum efficiency (EQE) spectra were recorded with an EQE measurement system (Newport, USA).

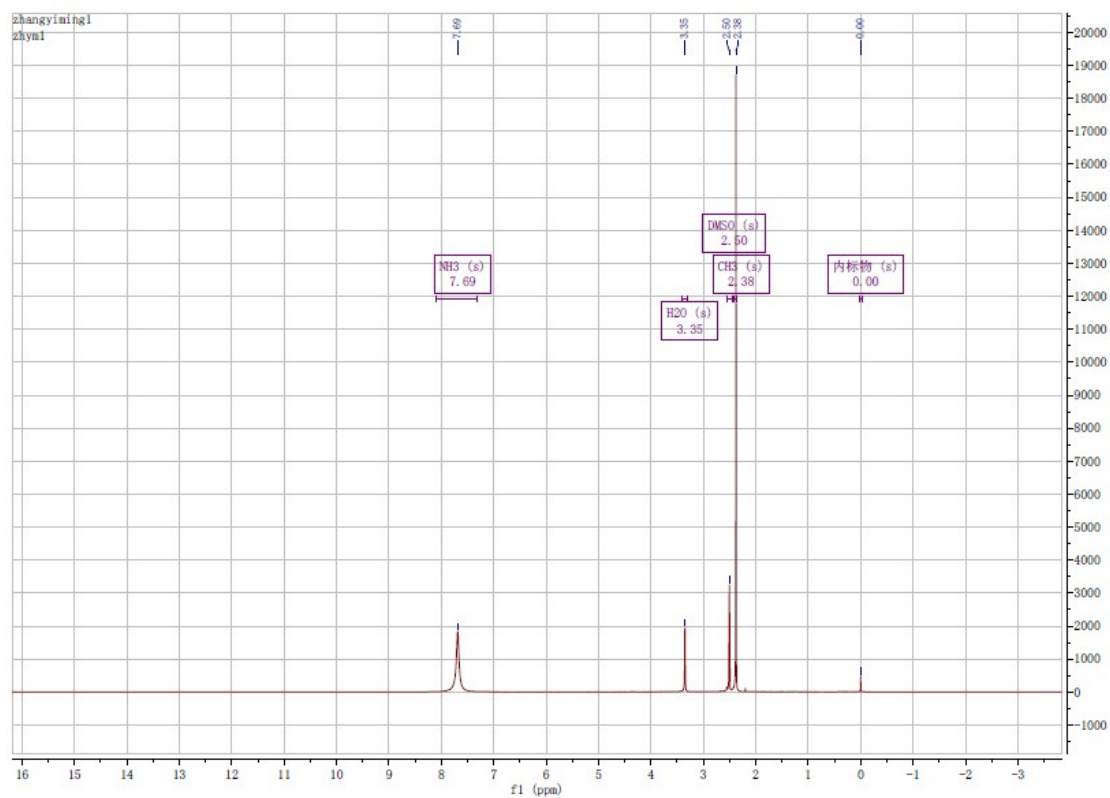
## Supplementary Figures



**Figure S1.** Photograph of 70 wt% clear solution of MA<sup>+</sup>TFA<sup>-</sup> in DMF, demonstrating the high solubility.

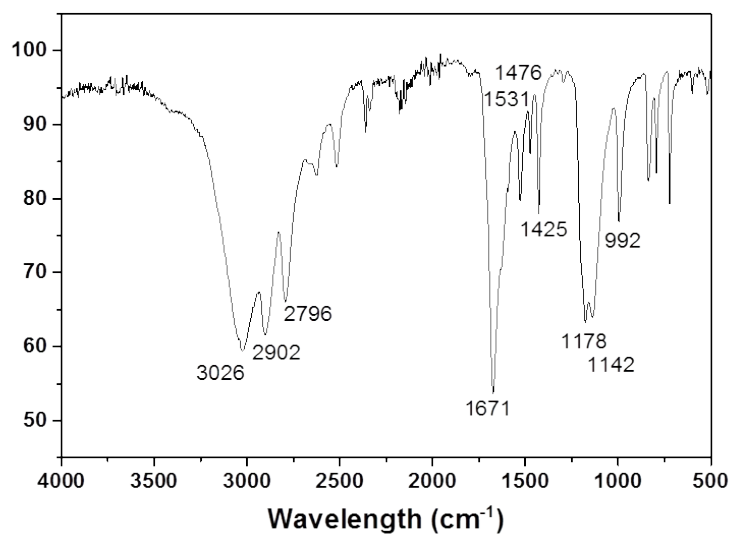


**Figure S2.** TG-DTA result of MA<sup>+</sup>TFA<sup>-</sup>, showing the melting point of 61.8 °C, and the decomposition onset at 152.4 °C and completion at 243.7 °C.

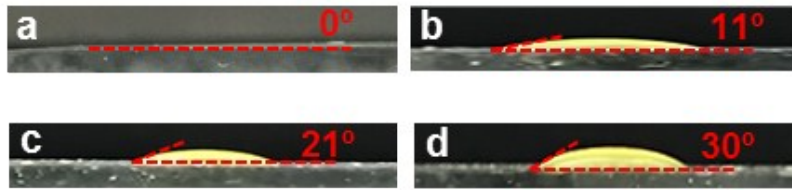


**Figure S3.** <sup>1</sup>H NMR spectrum (DMSO-d<sub>6</sub>, 400 MHz, TMS) of MA<sup>+</sup>TFA<sup>-</sup>.

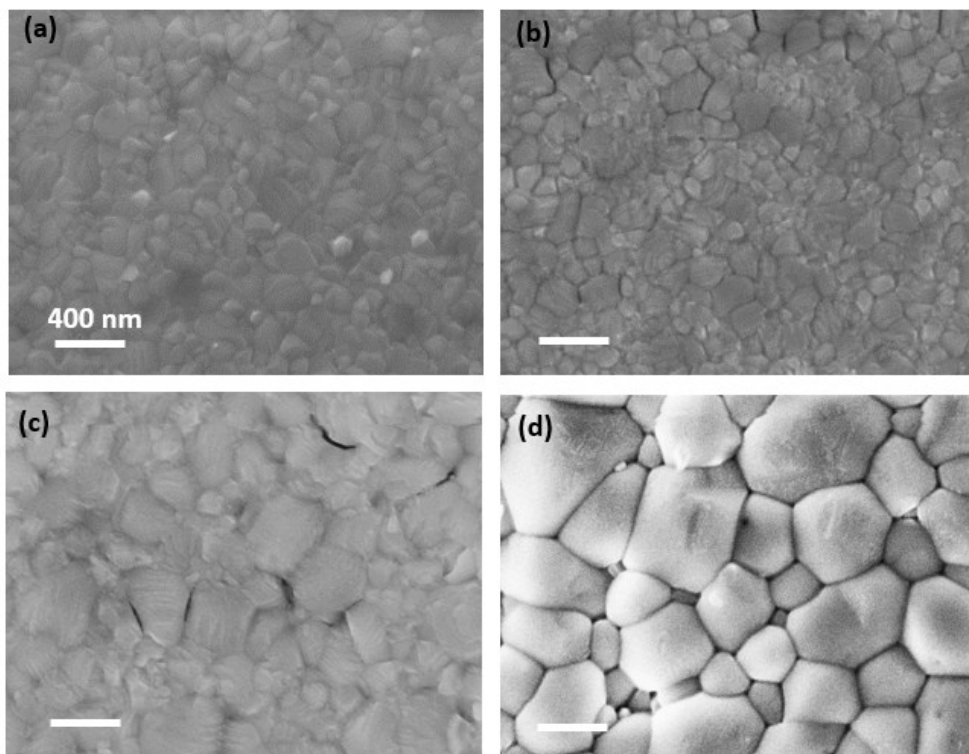
<sup>1</sup>H NMR:  $\delta$  7.69 (s, 4H), 2.38 (s, 3H), demonstrating the existing of CH<sub>3</sub>NH<sub>3</sub><sup>+</sup> cation in DMSO.



**Figure S4.** FTIR spectrum of MA<sup>+</sup>TFA<sup>-</sup>. The valleys are assigned as below: 3026 cm<sup>-1</sup> for  $\nu$  N-H, which confirms the existing of -NH<sub>3</sub>; 2902 cm<sup>-1</sup> for  $\nu^s$  C-H, 2796 cm<sup>-1</sup> for  $\nu^{as}$  C-H, 1476 cm<sup>-1</sup> for  $\delta^{as}$  C-H; 992 cm<sup>-1</sup> for  $\nu$  C-H, suggesting the existence of methyl group; 1425 cm<sup>-1</sup> for  $\delta^s$  C-H in -N-CH<sub>3</sub>, which confirms N atom is adjacent to methyl group, all above demonstrate the existence of CH<sub>3</sub>NH<sub>3</sub><sup>+</sup> cation. 1178 and 1142 cm<sup>-1</sup> for  $\nu$  C-F, 1671 cm<sup>-1</sup> for  $\nu$  C=O, 1531 cm<sup>-1</sup> for  $\nu$  C-O, all these prove the existing of the anion CF<sub>3</sub>COO<sup>-</sup>.

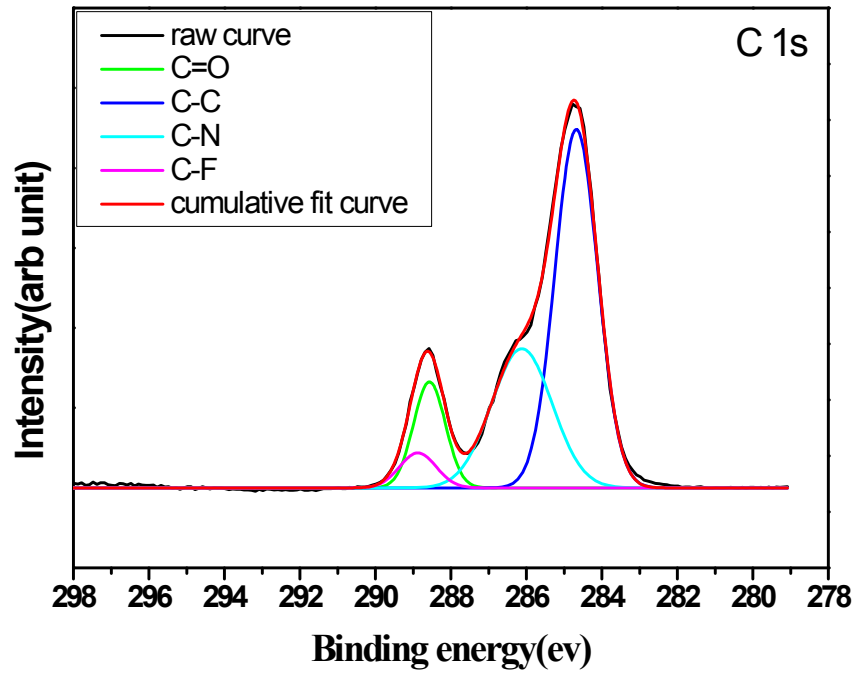


**Figure S5.** Cross-sectional optical images of MAPbI<sub>3</sub> perovskite solution droplets on compact-TiO<sub>2</sub>-coated FTO-glasses with the increasing weight ratio of MA<sup>+</sup>TFA<sup>-</sup> to MAPbI<sub>3</sub>: (a) 0; (b) 1:35; (c) 1:15, (d) 1:10.

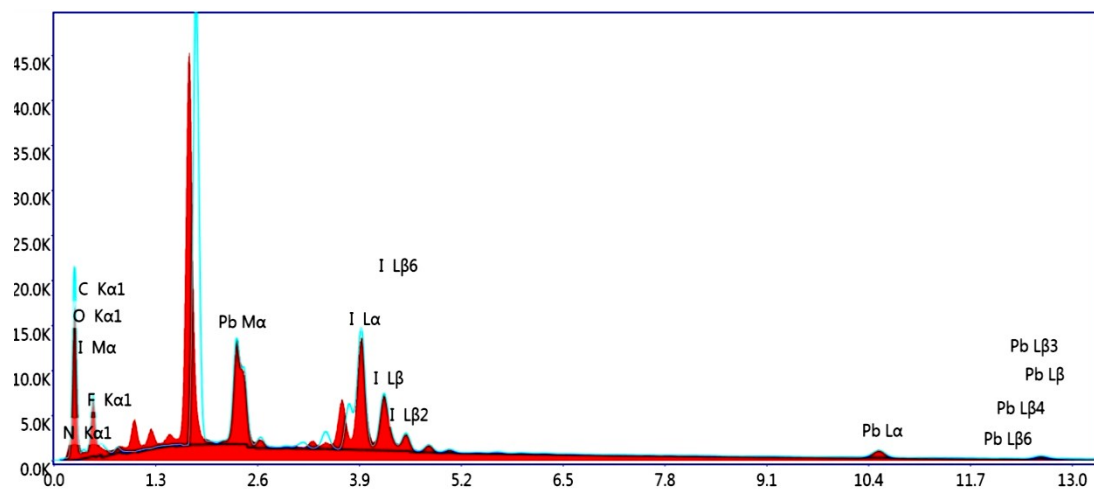


**Figure S6.** SEM images of MAPbI<sub>3</sub> perovskite thin films on compact-TiO<sub>2</sub>-coated FTO-glasses made with different weight ratios of MA<sup>+</sup>TFA<sup>-</sup> to MAPbI<sub>3</sub>: (a) 0; (b) 1:35; (c) 1:15; (d) 1:10. Note that (a) and (d) are reproduced from Figure 1c and 1d.

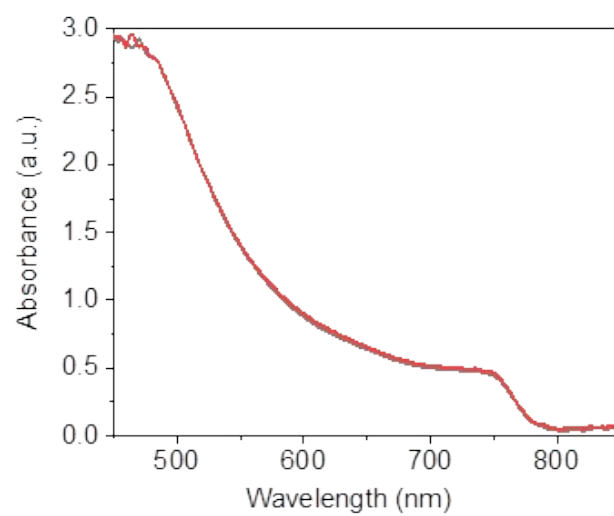




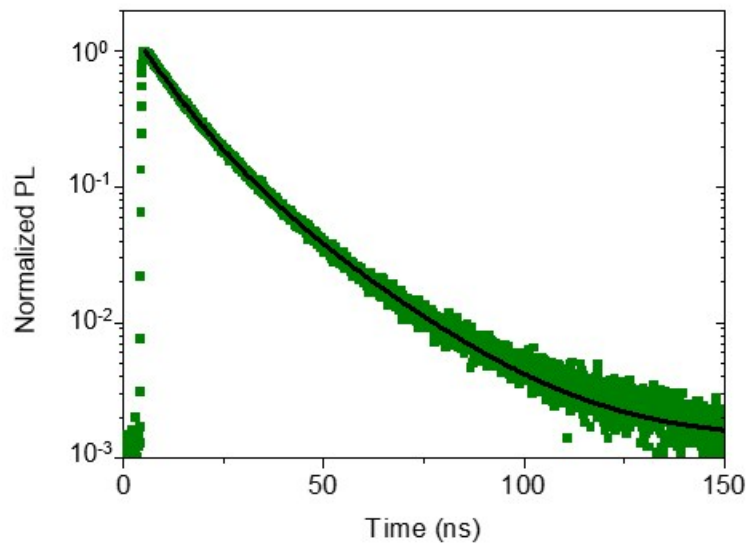
**Figure S7.** C 1s XPS of MAPbI<sub>3</sub> perovskite thin film made with MA<sup>+</sup>TFA<sup>-</sup>.



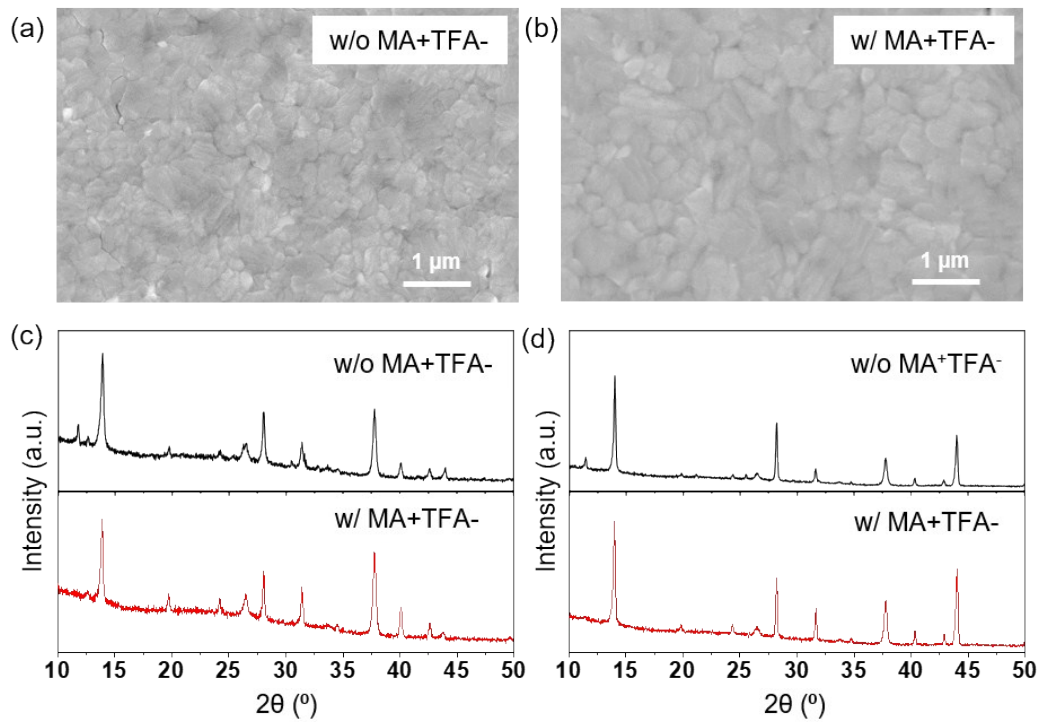
**Figure S8.** EDX spectrum of MAPbI<sub>3</sub> perovskite thin film made with MA<sup>+</sup>TFA<sup>-</sup>.



**Figure S9.** UV-vis absorption spectra of MAPbI<sub>3</sub> perovskite thin films made without (grey solid line) and with (red solid line) MA<sup>+</sup>TFA<sup>-</sup> additive.

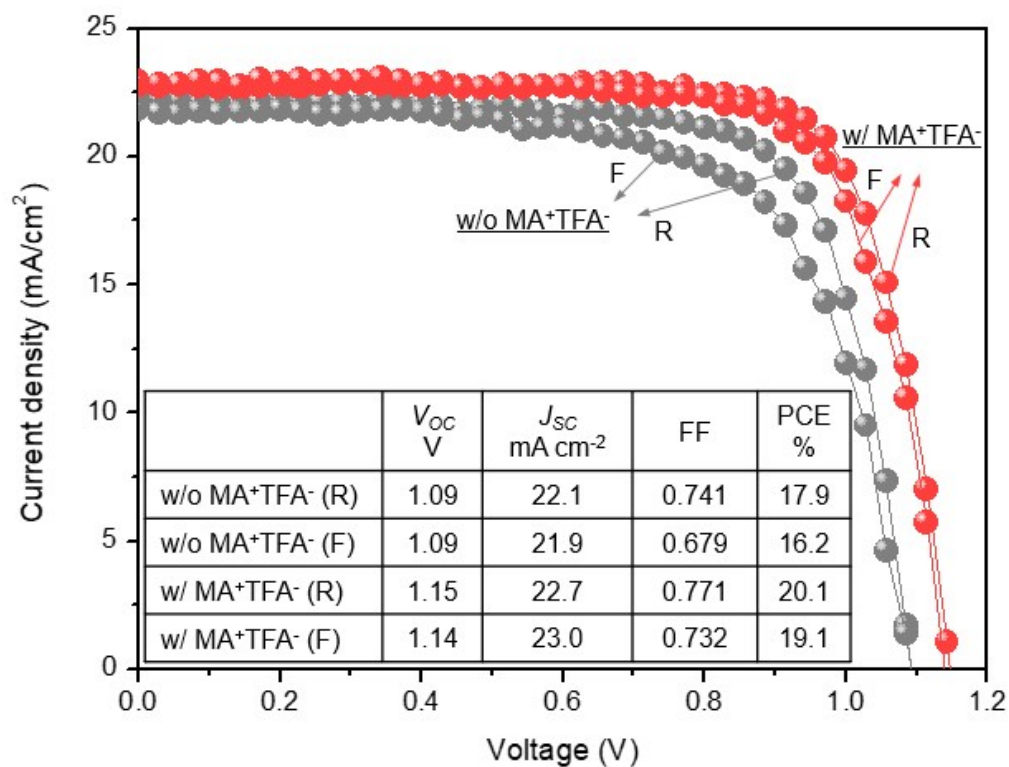


**Figure S10.** Time-resolved PL spectrum of the MAPbI<sub>3</sub> perovskite thin film that is made using solvent annealing method [ref: doi:10.1002/adma.201401685] and exhibit a similar grain size to the film made with MA<sup>+</sup>TFA<sup>-</sup> additive in this study. The spectrum is fit using a bi-exponential function and the fitting parameters are included in Table S1.



**Fig**

**Figure S11.** SEM images of the FAPbI<sub>3</sub> perovskite thin film made (a) without and (b) with MA<sup>+</sup>TFA<sup>-</sup> additive. (c) XRD patterns of the FAPbI<sub>3</sub> perovskite thin film made without and with MA<sup>+</sup>TFA<sup>-</sup> additive after storage 48-h exposure to the controlled humid condition (70% RH, RT). (d) XRD patterns of the MA<sub>0.7</sub>FA<sub>0.3</sub>PbI<sub>3</sub> perovskite thin film made without and with MA<sup>+</sup>TFA<sup>-</sup> additive after storage 48-h exposure to the controlled humid condition (70% RH, RT).



**Figure S12.** J-V curves at both forward (F) and reverse (R) scans for the best PSCs made without and with MA<sup>+</sup>TFA<sup>-</sup> additive. Inset shows the extracted J-V parameters.

**Table S1.** Time constants for fitting the PL decays in Figure 3b using bi-exponential functions.  $\tau_{\text{avg}}$  is the amplitude average PL lifetime.

	$\tau_1$	$\tau_2$	$\tau_{\text{avg}}$
w/ MA <sup>+</sup> TFA <sup>-</sup>	10.9 ns	20.6 ns	15.6 ns
w/o MA <sup>+</sup> TFA <sup>-</sup>	6.1 ns	24.0 ns	6.3 ns
w/ MA <sup>+</sup> TFA <sup>-</sup> (solvent-annealed)	8.8 ns	20.5 ns	12.2 ns